



PATENT
790001-2016.1D

JPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Takashi Yoshitomi et al.
Serial No. : 10/619,394
Filed : July 15, 2003
For : SEMICONDUCTOR DEVICE WITH CAPACITOR AND PROCESS
FOR MANUFACTURING THE DEVICE
Examiner : Christian D. Wilson
Art Unit : 2824

745 Fifth Avenue
New York, NY 10151
Tel: 212-588-0800

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an amendment in the above-identified application.

- ☐ No additional fee is required.
☒ The fee has been calculated as shown below.
☐ This is an application of a small entity under 37 CFR 1.9(f), and the amounts shown in parentheses apply.

Claims as Amended

(1)	(2) Claims remaining after amendment	(3)	(4) Highest number previously paid for	(5) Present extra	(6) Rate	(7) Additional Fee
Total claims	13	Minus	** = 20	* 0 x	\$18 (9)	= \$ 0.00
Independent claims	1	Minus	*** = 3	* 0 x	\$86 (43)	= \$ 0.00
Total additional fee for this amendment						\$ 0.00

* If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

** If the highest number of total claims previously paid for is less than 20, write "20" in this space.

*** If the highest number of independent claims previously paid for is less than 3, write "3" in this space.

- ☐ This application contains a multiple dependent claim. The required fee of \$290(145) has been previously paid ☐, or is paid herewith ☐.
- ☒ This response is being filed within the first month following the expiration of the term originally set therefor. This is a petition to request a one-month extension of time. A check covering the cost of the petition is enclosed.
- ☒ A check in the amount of \$110.00 is attached, which covers the cost of ☐ additional claims ☒ petition for extension of time.
- ☐ Charge \$_____ to Deposit Account No. 50-0320.
- ☒ Please charge any additional fees incurred by reason of this response or credit any overpayment to Deposit Account No. 50-0320.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 22, 2004.
Bruno Polito, Reg. No. 38,580

Name of Applicant, Assignee or Registered Representative

Signature

July 22, 2004

Date of Signature

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP
Attorneys for Applicant(s)

By:

Bruno Polito
Reg. No. 38,580
Tel: 212-588-0800

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Bruno Polito, Reg. No. 38,580

Name of Applicant, Assignee or Registered Representative



Signature

July 22, 2004

Date of Signature

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed April 21, 2004, please amend the above-
identified patent application as follows: